

# United States Patent and Trademark Office



UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.uspto.gov

APPLICATION NO.	FI	LING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO
10/721,524 11/25/2003		Richard A. Blanchard	03-C-040 (850063.602)	5333	
30423	7590	11/03/2004		EXAMINER	
		ONICS, INC.	ERDEM, FAZLI		
MAIL STAT		=	ART UNIT	PAPER NUMBER	
CARROLLI	TON, TX	75006	2826		
				DATE MAILED: 11/03/2004	1

Please find below and/or attached an Office communication concerning this application or proceeding.

<del></del>		Application No.	Applicant(s)	
		10/721,524	BLANCHARD ET AL.	
Office Action Summary		Examiner	Art Unit	
		Fazli Erdem	2826	
Period f	The MAILING DATE of this communication ap or Reply	pears on the cover sheet	with the correspondence address	
THE - Exte afte - If th - If NO - Fail Any	HORTENED STATUTORY PERIOD FOR REPL MAILING DATE OF THIS COMMUNICATION. ensions of time may be available under the provisions of 37 CFR 1. r SIX (6) MONTHS from the mailing date of this communication. e period for reply specified above is less than thirty (30) days, a reply period for reply is specified above, the maximum statutory period ure to reply within the set or extended period for reply will, by statut reply received by the Office later than three months after the mailined patent term adjustment. See 37 CFR 1.704(b).	136(a). In no event, however, may oly within the statutory minimum of t I will apply and will expire SIX (6) M te, cause the application to become	a reply be timely filed  hirty (30) days will be considered timely.  ONTHS from the mailing date of this communication.  ABANDONED (35 U.S.C. § 133).	
Status				
1)🖾	Responsive to communication(s) filed on 24 S	September 2004.		
2a)□	This action is <b>FINAL</b> . 2b)⊠ Thi	s action is non-final.		
3)□	Since this application is in condition for allowated in accordance with the practice under	•	•	
Disposit	tion of Claims			
4)⊠ 5)⊠ 6)⊠ 7)⊠ 8)□	· / <del></del>	awn from consideration.		
Applicat	ion Papers		· · ·	
9)[	The specification is objected to by the Examin	er.		
10)☐ The drawing(s) filed on is/are: a)☐ accepted or b)☐ objected to by the Examiner.				
	Applicant may not request that any objection to the	e drawing(s) be held in abey	ance. See 37 CFR 1.85(a).	
11)	Replacement drawing sheet(s) including the correct The oath or declaration is objected to by the E	· ·	• • • • • • • • • • • • • • • • • • • •	
Priority :	under 35 U.S.C. § 119	,		
а)	Acknowledgment is made of a claim for foreign All b) Some * c) None of:  1. Certified copies of the priority document 2. Certified copies of the priority document 3. Copies of the certified copies of the priority application from the International Bureassee the attached detailed Office action for a list	nts have been received. Its have been received in ority documents have been in (PCT Rule 17.2(a)).	Application No en received in this National Stage	
Attachmen	at(s)			
1) 🔯 Notic	ce of References Cited (PTO-892)	4) Interview	v Summary (PTO-413)	
3) 🔲 Infor	ce of Draftsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO-1449 or PTO/SB/08 er No(s)/Mail Date	_ Paper N	o(s)/Mail Date f Informal Patent Application (PTO-152)	

### **DETAILED ACTION**

Page 2

#### Allowable Subject Matter

- 1. Claims 34-44 allowed.
- 2. Claims 14-17 and 20-24 objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.
- 3. The following is a statement of reasons for the indication of allowable subject matter:

  Prior art failed to establish the required relationship between the first and the second beam with respect to the first and the second trench.

## Claim Rejections - 35 USC § 103

- 4. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 5. Claims 1-12 and 25-27 rejected under 35 U.S.C. 103(a) as being unpatentable over Shaw et al. (5,610,335) in view of Shaw et al. (5,847,454).

Regarding Claims 1-12 and 25-27, Shaw et al. '335 disclose a microelectromechancial lateral accelerometer where in Fig. 17, cantilever type beam 380 is disposed inside trench 410 with insulating layer 403, and conductive plates 404 and 406. Beam is connected to substrate 390 on one portion with connector 396. The second portion of the beam is spaced apart from the walls of the trench 411. Shaw et al. '335 fail

Art Unit: 2826

to specifically disclose that one portion of the beam is movable and the other portion is fixed/attached/connected to the substrate. However, Shaw et al. '454 disclose electrically-isolated released microstructures where in Claim 1, Shat et al. disclose a beam with one portion interconnected and one portion movable.

It would have been obvious to one of having ordinary skill in the art at the time the invention was made to include the required movable and connected portions of the cantilever beam in Shaw et al. '335 as taught by Shaw et al. '454, in order to have a semiconductor device with more functionality.

6. Claims 13, 18 and 19 rejected under 35 U.S.C. 103(a) as being unpatentable over Shaw et al. (5,610,335) in view of Shaw et al. (5,847,454) further in view of Mizukoshi (5,503,017).

Regarding Claims 13, 18 and 19, Shaw et al. '335 disclose a microelectromechancial lateral accelerometer where in Fig. 17, cantilever type beam 380 is disposed inside trench 410 with insulating layer 403, and conductive plates 404 and 406. Beam is connected to substrate 390 on one portion with connector 396. The second portion of the beam is spaced apart from the walls of the trench 411. Shaw et al. '335 fail to specifically disclose that one portion of the beam is movable and the other portion is fixed/attached/connected to the substrate and the required first and the second beams inside the first and the second trenches. However, Shaw et al. '454 disclose electrically-isolated released microstructures where in Claim 1, Shat et al. disclose a beam with one portion interconnected and one portion movable. Furthermore, Mizukoshi discloses a semiconductor acceleration sensor where in Fig. 4, it is disclosed irst and second beams disposed inside first and second trenches.

Art Unit: 2826

It would have been obvious to one of having ordinary skill in the art at the time the invention was made to include the required movable and connected portions of the cantilever beam and the first and the second beams inside the first and the second trenches in Shaw et al. '335 as taught by Shaw et al. '454 and Mizukoshi respectively, in order to have a semiconductor device with more functionality.

#### Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Fazli Erdem whose telephone number is (571) 272-1914. The examiner can normally be reached on M - F 8:00 - 5:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nathan Flynn can be reached on (571) 272-1915. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

FE November 1, 2004 Art Unit: 2826

NATHAN J. FLYNN SUPERVISORY PATENT EXAMINER TECHNOLOGY CENTER 2800